



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Oh-sung Song et al.

Serial No. 10/608,221

Filed: June 30, 2003

FOR: METHOD FOR FABRICATING MOS SEMICONDUCTOR DEVICE HAVING
SALICIDE REGION AND LDD REGION

STATUS CHECK

U.S. Patent and Trademark Office
220 20th Street S.
Customer Window
Crystal Plaza Two, Lobby, Room 1B03
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Sir:

Kindly immediately advise the undersigned of the status of the above-identified
application.

Respectfully submitted,

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Date: October 18, 2004